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JUN 28 2004

Docket No.: 5545 (2616-012)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Gene LEE et al.

OFFICIAL

Appln. No.: 10/039,333

Group Art Unit: 1765

Filed: November 9, 2001

Examiner: B. Tran

Title: Method for Etching Tungsten
Using NF_3 and Cl_2

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In reply to the Office Action mailed February 27, 2004, the period for reply having been extended by petition to June 28, 2004 (June 27, 2004 falling on a Sunday), the application is amended as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks begin of page 8 of this paper.

Date: June 28, 2003

Atty. Dkt. No.: 5545 (2616-012)